TRA	NSMITTAL O	Docket No.		
. (Under 37 CFR 1.97(b) or 1.97(c))				11675.114
In Re	Application Of:			
Kei-Y		6 200 E		
		Filipe Date April 30, 1997	Examiner	Group Art Unit
	08/846,671	April 30, 1997	George Goudreau	1763
Title:	UNDOPED SILI	ICON DIOXIDE AS ETCH STOP	FOR SELECTIVE ETCH OF D	OPED SILICON DIOXIDE
		Δι	ddress to:	
		Assistant Comm	missioner for Patents	
		wasningto	on, D.C. 20231	
		37 CF	FR 1.97(b)	
1. 🔲	The Information	Disclosure Statement submitted	herewith is being filed within the	ree months of the filing
	CFR 1.491 in a	n international application; or be	he date of entry of the national s	stage as set forth in 37
	merits, whicheve	er event occurs last.	note the maining date of a me	St Office Action on the
		37 CF	FR 1.97(c)	
2. 🛚	The Information	Disclosure Statement submitted	herewith is being filed after thr	ee months of the filing
	or a national app	olication, or the date of entry of the olication; or after the mailing date	the national stage as set forth in	in 37 CFR 1 401 in an
	occurred last but	before the mailing date of either:	te of a first Office Addition on	the merits, whichever
	1. a	a Final Action under 37 CFR 1.113	3, or	
	2. a	a Notice of Allowance under 37 CI	FR 1.311,	
	whicheve	er occurs first.		
	Also submitted he	erewith is:		~
				.7.3
	a certificati	ion as specified in 37 CFR 1.97(e)	);	700 700
		OR		RECEIVED  CT IS 2 int  TC 1700 ITAL Statement sclosure Story
	★ the fee set	t forth in 37 CFR 1.17(p) for su	ubmission of an Information Dis	eclosura Statement //
	under 37 C	CFR 1.97(c).		NO NO
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TRANSMITTAL OI	FINFORMATION DISCLO	SURE STATEMENT	Docket No. 11675.114
In Re Application Of: Kei-Yu- Ko	OCT 0 6 2000 G		
Serial No.	RADEMENING Date	Examiner	Group Art Unit
08/846,671	April 30, 1997	George Goudreau	1763
Title: UNDOPED SILI	CON DIOXIDE AS ETCH STOP	FOR SELECTIVE ETCH OF D	OPED SILICON DIOYIDE
			or 22 Sillicon Blombe
			7C 17
as described belo  Charge the Credit any Charge and Certificate of The Control of	(Only complete if Applicant elects to count of \$240.00 is attainmissioner is hereby authorized w. A duplicate copy of this sheet the amount of yoverpayment.  Transmission by Facsimile*  ocument and authorization to charge gracsimile transmitted to the United	to charge and credit Deposit Ac	by First Class Mail and fee is being deposited in the U.S. Postal Service as 1.8 and is addressed to the
(Date)	Signature	Signature of Person Mail	er ling Correspondence
Typed or Printed N	ame of Person Signing Certificate	Typed or Printed Name of Perso	
deposit account.  Signature  Bradley K. DeSandro  Reg. No. 34,521	only be used if paying by	Dated: Otolan 3,2	
022901			
PATENT TRADEMARK	OFFICE		
oc:			



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In is the first in the second	of:	)	
	Kei-Yu Ko	)	413
Serial No.:	08/846,671	) ) Art Unit	10/18/10
Filed:	April 30, 1997	) 1763 )	'M
For:	UNDOPED SILICON DIOXIDE AS ETCH STOP FOR SELECTIVE ETCH OF DOPED SILICON DIOXIDE	)· ) )	
Examiner:	George Goudreau	TC 1700 MAIL	RECEIVE
	INFORMATION DISCLOSURE STATEMENT UNDER 37 C.F.R. § 1.97	ROOM	error 1 1

Assistant Commissioner for Patents Washington, D.C. 20231

Sir:

Please find, pursuant to 37 C.F.R. § 1.98(a)(1), the enclosed Form PTO-1449 which contains a list of all patents, publications, or other items that have come to the attention of one or more of the individuals designated in 37 C.F.R. § 1.56(c). While no representation is made that any of these references may be "prior art" within the meaning of that term under 35 U.S.C. §§ 102 or 103, the enclosed list of references is disclosed so as to fully comply with the duty of disclosure set forth in 37 C.F.R. § 1.56.

Moreover, while no representation is made that a specific search of office files or patent office records has been conducted or that no better art exists, the undersigned attorney of record believes that the enclosed art is the closest to the claimed invention (taken in its entirety) of which the undersigned is presently aware, and no art which is closer to the claimed invention (taken in its entirety) has been knowingly withheld.

Statement of References Previously Disclosed
Under 37 C.F.R. § 1.98(d)

they were previously cited by or submitted to the Office in application number 08/958,290, filed on October 27, 1997, which is relied upon for an earlier filing date under 35 U.S.C. §

120.

## **United States Patent Documents**

Patent Number	Issue Date	Name	Class	Sub <u>Class</u>	Filing <u>Date</u>
5,323,047	6-21-94	Nguyen Lin et al. Karnett	257	758	1-31-92
5,485,035	1-16-96		257	637	12-28-93
4,818,335	4-4-89		156	644	5-13-88

## Foreign Patent Documents

Patent Number	Issue Date	Country	Class	Sub <u>Class</u>	Filing <u>Date</u>
04 345 054	12_1_92	Ianan			

Dated this 3 day of September, 2000

Respectfully submitted,

BRADLEY K. DESANDRO

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